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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL 50 CLAIMS 11	INDEPENDENT 7 CLAIMS 3
Verified and Acknowledged	 Examiner's Signature	 Initials			

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## TITLE

Atomic layer deposition apparatus

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees
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